Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L9	98	self adj assembling adj monolayer same substrate	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2006/02/03 15:06
L10	108	self adj assembling near2 monolayer same substrate	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2006/02/03 15:08
L12	8	((monocrystalline or polycrystalline) and self$1assembl$4 and monolayer and substrate).clm.	US-PGPUB	OR	OFF	2006/02/03 15:10